

ICMAP 2018

The 7th International Conference on Microelectronics and Plasma Technology

July 24-28, 2018 / Songdo ConvensiA, Incheon, Korea



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Kuntack Lee received the BS in Chemistry from Seoul National University and the MS and Ph.D. in Physical Chemistry from Pohang University of Science and Technology. From 1996, Kuntack Lee started his work at Samsung as a member of cleaning group. He researched various kinds of cleaning equipments including drying, surface modification, dry clean, electroplating, etc. From 2003 to 2005, he did research at Imec industrial affiliation program. He has served as a committee member of UCPSS, world famous symposium from 2010. He received Samsung Award of Honor in 2013 for his achievement of equipment development. He became a Master of Samsung in the field of next generation equipment development in 2015. Recently he has worked for advanced core equipment development and it's productivity and quality.